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CONFIRMATION NO. 8409

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**** CONTINUING DATA *******

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**** FOREIGN APPLICATIONS *******

RERIGHT PUBLICATIONS
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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	/PAPE A SENE/ <u>Examiner's Signature</u>	Initials	BELGIUM	3	10	2

ADDRESS

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UNITED STATES

TITLE

SEMICONDUCTOR SUBSTRATE WITH SOLID PHASE EPITAXIAL REGROWTH WITH REDUCED JUNCTION LEAKAGE AND METHOD OF PRODUCING SAME

FILING FEE RECEIVED 900	<p>FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:</p>	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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